MICRON.092CP1





PATENT

IN THE UNITED STATES PATENTAND TRADEMARK OFFICE

Applicant

Stephen L. Willis

Appl. No.

09/552,383

Filed

April 19, 2000

For

CHEMICAL MECHANICAL

PLANARIZATION OF

CONDUCTIVE MATERIAL

Group Art Unit Unknown

I hereby certify that being deposited with marked attachments Service as first-class the United States Pa mail in an envelop dressed to: Assistant Washington, D.C. 20231, 00

, Reg. No. 37,743 Michael H. Tre

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Please amend the above-captioned application as follows:

IN THE SPECIFICATION:

After the title and before the section entitled "Background Information" please add 4This application is a continuation-in-part application of U.S. Application No. 09/309,460, filed entitled CHEMICAL MECHANICAL PLANARIZATION OF CONDUCTIVE

MATERIAL F.

Please charge any fees to Deposit Account No. 11-1410. A duplicate copy of this sheet is enclosed.

080100

Respectfully submitted,

KNOBBE, WARTENS, OLSON & BEAR, LLP

By:

Michael H. Trenholm Registration No. 37,743 Attorney of Record 620 Newport Center Drive Sixteenth Floor Newport Beach, CA 92660

(909) 781-9231

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